

# Self-powered and highly efficient ion-diffused MAPbBr<sub>3</sub> single crystal-based UV-Vis photodiode

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## **Abstract:**

The p-n junction region of the perovskite single crystals (PSC) made by doping metallic ions through a solution-processed method is too large (more than 10 μm). The carrier drift length ( $\mu\tau E$ ), on the other hand, needs to be greater than the detector's dimension in order to achieve high responsivity. Also, a high bias voltage is required if the p-n junction is particularly thick. For the practical use of a photodiode, a thicker pn junction is not good. So, finding a way to create a narrow p-n junction area of PSC is a need of the time. To achieve this goal, we offer a successful method for generating a narrow p-n junction area by metallic ion diffusion. By narrowing pn junction we have achieved high performance of photodiode with a low trap density ( $1.6108 \text{ cm}^{-3}$ ), high mobility ( $423 \text{ cm}^2\text{V}^{-1}\text{s}^{-1}$ ), and reduced dark current density ( $0.5 \text{ Acm}^{-2}$ ) along with remarkably enhanced responsivity ( $77.69 \text{ AW}^{-1}$ ) for  $30 \text{ Wcm}^{-2}$  UV light at a low applied voltage of 15 V, and detectivity of ( $1.6 \text{ 1015 Jones}$ ). This method has given a tremendously fast switching speed with a rise/fall duration of 2/6 ns under 0 V bias and long-term stability for more than 3 months in the ambient air. The photodiode performance is studied for UV-Vis light illuminations at various intensities and compared with no diffused photodiode in order to understand the impact of illumination intensity on the narrowed junction-based devices. The results point to a technique that has the potential to create next-level photodiodes.